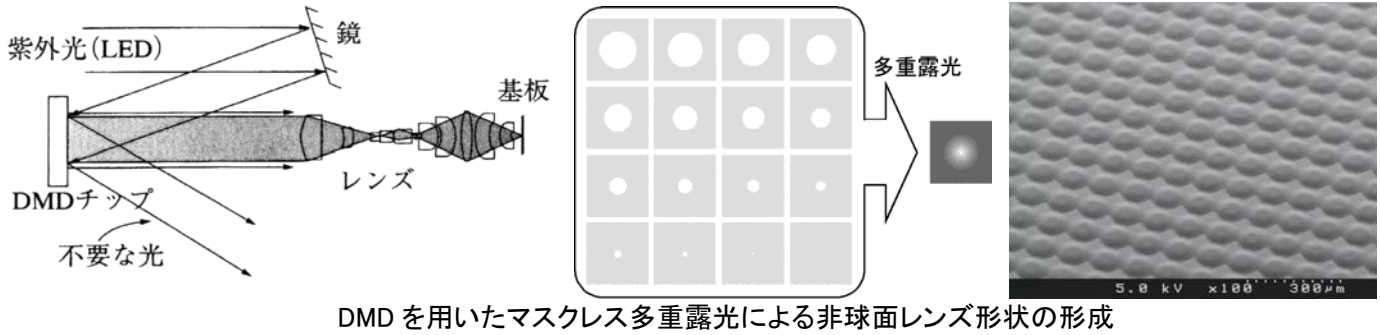
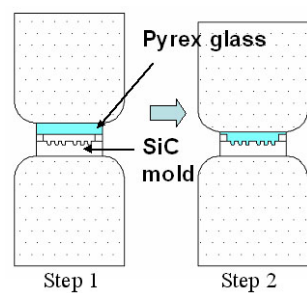
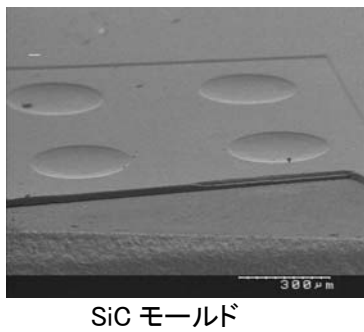
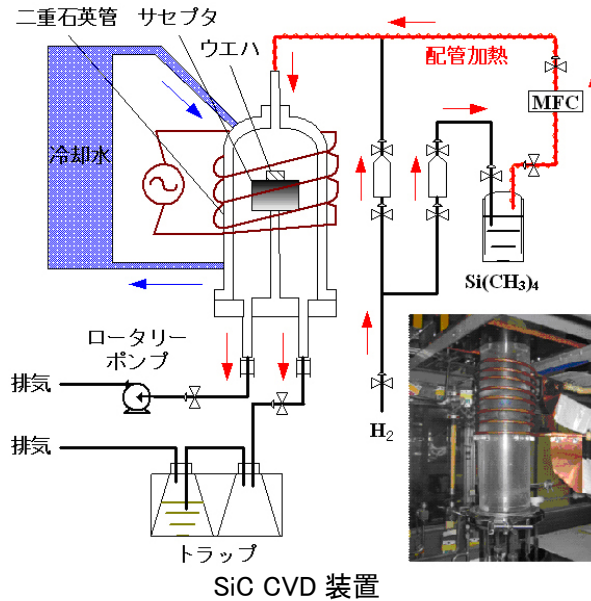
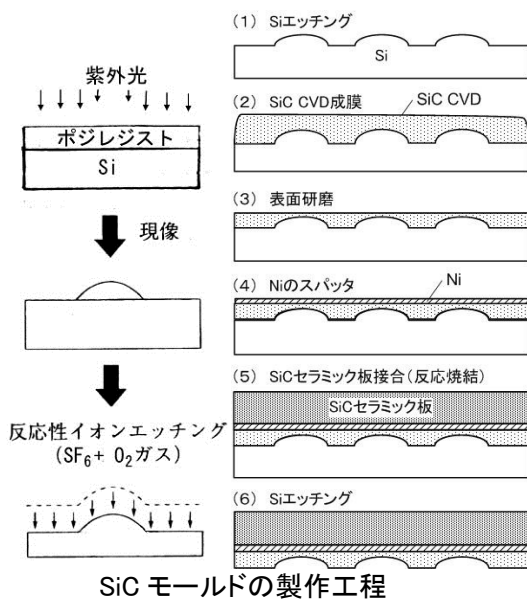


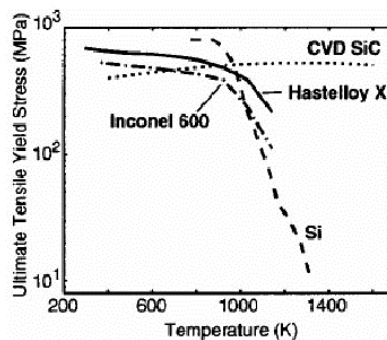
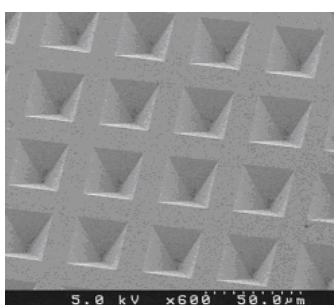
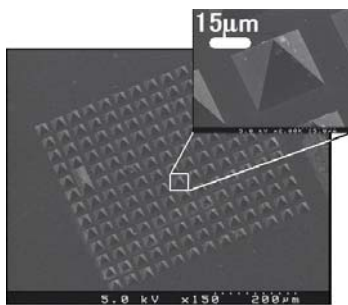
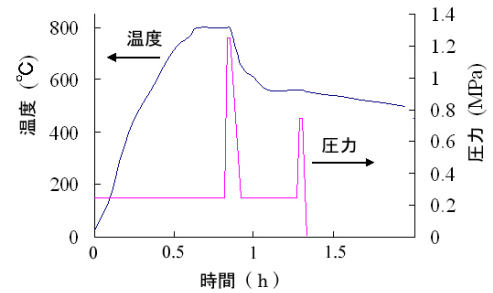
ガラスプレス成形のための炭化珪素(SiC)モールド



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ガラスプレス成形



SiC の高温での機械的強度(A.H.Epstein, J. of Eng. for Gas Turbines and Power, 126, (2004) 205)

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